

#5/Amot
A
8/13/02
V/SPATENT
2332-0117P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: KIM, Jeong Soo, et al. Conf. No.: 4564
Appl. No.: 09/998,134 Group: 2823
Filed: December 3, 2001 Examiner: Thanh V. PHAM
For: METHOD OF FORMING A JUNCTION IN SEMICONDUCTOR
DEVICE USING HALO IMPLANT PROCESSING (As Amended)

AMENDMENT

Honorable Commissioner of Patents
Washington, D.C. 20231

August 8, 2002

Sir:

In response to the Examiner's Office Action dated May 8, 2002, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

FAX COPY RECEIVED

AUG 8 2002

TECHNOLOGY CENTER 2800

IN THE TITLE

Please replace the present title with the following: —

--METHOD OF FORMING A JUNCTION IN SEMICONDUCTOR DEVICE
USING HALO IMPLANT PROCESSING--

IN THE CLAIMS

Please cancel claim 3 without prejudice or disclaimer to the subject matter contained therein.